

STUDY MODULE DESCRIPTION FORM		
Name of the module/subject New technology in electromechanics		Code 1010325341010324892
Field of study Electrical Engineering	Profile of study (general academic, practical) general academic	Year /Semester 2 / 4
Elective path/specialty Electrical Systems in Mechatronics	Subject offered in: Polish	Course (compulsory, elective) obligatory
Cycle of study: Second-cycle studies	Form of study (full-time, part-time) part-time	
No. of hours Lecture: 9 Classes: - Laboratory: - Project/seminars: -		No. of credits 1
Status of the course in the study program (Basic, major, other) major		(university-wide, from another field) from field
Education areas and fields of science and art technical sciences Technical sciences		ECTS distribution (number and %) 1 100% 1 100%
Responsible for subject / lecturer: dr hab. inż. Dorota Stachowiak email: dorota.stachowiak@put.poznan.pl tel. 61 665 3950 Faculty of Electrical Engineering ul. Piotrowo 3A 60-965 Poznań		
Prerequisites in terms of knowledge, skills and social competencies:		
1	Knowledge	Knowledge of electromagnetic field theory, electrical engineering and electrostatics, knowledge of construction of the energy transducers.
2	Skills	The skill of effective self-education in a field related to the selected field of study.
3	Social competencies	Skills in teamwork and proper verbal communication, the awareness of the need to broaden their competences and knowledge, a willingness to work together as a team.
Assumptions and objectives of the course: The main goal is to get acquainted with the modern applications of the phenomena associated with the electromagnetic field. Knowledge of principles of operation, property and construction of electromechanical transducers discussed.		
Study outcomes and reference to the educational results for a field of study		
Knowledge: 1. Know the structure of selected electromechanical and electromagnetic cyclic and acyclic transducers and systems that use the energy phenomena: superconductivity, magnetic levitation - [K_W03++ K_W10+]		
Skills: 1. The student will be able to indicate the potential use of new technologies in the construction of the electromechanical transducers - [K_U01+++ K_U19+++]		
Social competencies: 1. . The student is aware of the value of his work, respect the principles of teamwork, takes responsibility for collaborative work - [K_K01 + K_K02 ++]		
Assessment methods of study outcomes		

<p>Lecture: -assessment of knowledge and skills by the completion of a written test, -continuous evaluation for each course (rewarding activity and quality of the expression).</p> <p>Extra points for the activity in the classroom, and in particular for: -discussion and proposition of additional aspects of the subjects, - comments related to the improvement of teaching materials, - quality and diligence of the developed reports.</p>		
Course description		
<p>Superconductivity and its applications, magnetic separators, magnetic levitation, magnetic bearings. Electrotechnology. Structure and properties of magnetic fluid. Magnetic fluid applications. Mechatronic elements: sensors and actuators. Microelectromechanical systems (MEMS): microsensors, microactuators, silicon technology applications. Nanotechnology, nanomachines. Updating 2017: Structure and properties of shape memory alloys. Shape memory alloys applications.</p> <p>Methods of education: - lecture with multimedia presentation supplemented with examples given on the board, - interactive lecture with questions to students, - student activity is taken into account during the course of the assessment process.</p>		
Basic bibliography:		
<p>1. 1. Stankowski J., Czyżak B., Nadprzewodnictwo, Wydawnictwa Naukowe-Techniczne; Warszawa; 1994. 2. 2. Burcan J., Łożyska wspomagane polem magnetycznym, Wydawnictwa Naukowo-Techniczne, Warszawa; 1996. 3. 3. Ławniczak A., Milecki A.: Ciecze elektro- i magneto-reologiczne oraz ich zastosowania w technice, WPP1999. 4. 4. Schmid D., Mechatronika, tłum. z niem. oprac. wersji pol. Olszewski M., Wyd. REA, Warszawa 2002.</p>		
Additional bibliography:		
<p>1. 1. Bishop R. H., The Mechatronics Handbook, Austin, Texas, CRC Press 2002 2. 2. Gad-el-Hak M. The MEMS Handbook, CRC Press 2006 3. 3. Hoffmann K. H., Functional Micro and Nanosystems, Springer ? Verlag Berlin Heidelberg 2004.</p>		
Result of average student's workload		
Activity		Time (working hours)
1. Lectures		9
2. Participate in the consultations on the lecture		6
3. Prepare for the completion		15
4. Participate in the completing		2
Student's workload		
Source of workload	hours	ECTS
Total workload	25	1
Contact hours	30	1
Practical activities	0	0